

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Norman Shendon et al. Art Unit : Unknown
Serial No. : Unassigned Examiner : Unknown
Filed : Herewith
Title : FLUID-PRESSURE REGULATED WAFER POLISHING HEAD

MAIL STOP PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are not enclosed.

Under 35 USC §120, this application relies on the earlier filing date of U.S. Application Serial No. 10/201,428, which is a continuation of U.S. Application Serial No. 09/892,143, filed June 25, 2001, which is a continuation of U.S. Application Serial No. 09/406,027, filed September 27, 1999, now U.S. Patent No. 6,290,577, which is a continuation of U.S. Application Serial No. 08/488,927, filed June 9, 1995, now U.S. Patent No. 6,024,630, each of which are incorporated herein by reference in their entirety.

The following references were submitted to and/or cited by the Office in the prior application and, therefore, are not provided in this application:

Desig. IDs:

AA-BJ, BL-CN

This statement is being filed with the application.

CERTIFICATE OF MAILING BY EXPRESS MAIL

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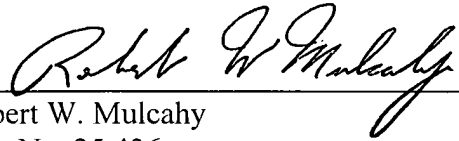
Applicant : Norman Shendon et al.
Serial No. : Unassigned
Filed :
Page : 2 of 2

Attorney's Docket No.: 05542-099006 / 770C6 CMP

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Respectfully submitted,

Date: OCTOBER 16, 2003



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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05542-099006	Application No. Unassigned
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Norman Shendon et al.	
		Filing Date Herewith	Group Art Unit Unknown

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	3,559,346	02/1971	Paola			
	AB	3,731,435	05/1973	Boettcher et al.			
	AC	4,256,535	03/1981	Banks			
	AD	4,270,316	06/1981	Kramer et al.			
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	AF	4,435,247	03/1984	Basi et al.			
	AG	4,519,168	05/1985	Cesna			
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	AT	5,329,732	07/1994	Karlsrud et al.			
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	AZ	5,476,414	12/1995	Hirose et al.			
	AAA	5,527,209	06/1996	Volodarsky et al.			

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05542-099006	Application No. Unassigned
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	Filing Date Herewith	Group Art Unit Unknown	

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	BA	5,569,062	10/1996	Karlsrud			
	BB	5,584,746	12/1996	Tanaka et al.			
	BC	5,584,751	12/1996	Kobayashi et al.			
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	BE	5,624,299	04/1997	Shendon			
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	BK	5,651,724	07/1997	Kimura et al.			
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	BM	5,733,182	03/1998	Miramatsu et al.			
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	BR	6,443,824	09/2002	Shendon et al.			

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	BS	0 156 746 A I	10/1985	EPO				
	BT	0 653 270 A I	08/1994	EPO				
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	BX	2 307 342 A	05/21/97	Great Britain				

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(37 CFR §1.98(b))			

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	CA	8631087	04/1987	Germany				
	CB	61-25768	02/1986	Japan				
	CC	63-114870	05/1998	Japan				
	CD	63-300858	12/1988	Japan				
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	CF	1-216768	08/1989	Japan				
	CG	2-243263	09/1990	Japan				
	CH	WO 94/19153	09/1994	WIPO				

Other Documents (include Author, Title, Date, and Place of Publication)

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	CJ	"High-Tech Resins Boost Chip Production", Machine Design, November 7, 1996, pp 52+. ["Machine Design"]
	CK	"Advanced Engineering Plastics for the Semiconductor Industry", DSM Engineering (Polymer Corporation), 1996. ["DSM"]
	CL	"Advanced Engineering Plastics for the Semiconductor Industry", DSM Engineering (Polymer Corporation), 1997. ["DSM"]
	CM	"SPM Purchase Orders for PPS Techtron Purchased from Laird Plastics, Invoice Copies from Laird", 1996. Laird Plastics
	CN	"SPM's PPS Ring Sales History", January 1997 thru November 1999

Examiner Signature	Date Considered
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